

INTERNATIONAL ELECTROTECHNICAL COMMISSION IEC Certification Scheme for Explosive Atmospheres

for rules and details of the IECEx Scheme visit www.iecex.com

Certificate No.:

IECEx LCI 09.0010X

issue No.:4

Status:

Current

Date of Issue:

2011-07-22

Page 1 of 5

Certificate history:

Issue No. 4 (2011-7-22) Issue No. 3 (2010-3-31) Issue No. 2 (2009-11-6) Issue No. 1 (2009-10-

28)

Issue No. 0 (2009-3-9)

Applicant:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

Electrical Apparatus:

Optional accessory:

Gas Chromatograph Analyzer - PGC5000A, PGC5000B, PGC5000C

Type of Protection:

ib py / d e py OR ib px / d e ib px OR nA nL / d e nA nL OR pz / d e pz

Marking:

For zone 1:

For PGC5000A: Ex ib py IIB+H2 T4 or For PGC5000A: Ex ib px IIB+H2 T4

For PGC5000B: Ex d e py IIB+H2, T4, T3 or T2 or For PGC5000B: Ex d e ib px IIB+H2, T4, T3 or T2 For PGC5000C: Ex d e py IIB+H2, T4, T3 or T2 or For PGC5000C: Ex d e ib px IIB+H2, T4, T3 or T2

For zone 2:

For PGC5000A: Ex nA nL IIB+H2 T4 or

For PGC5000A: Ex pz IIB+H2 T4

For PGC5000B: Ex d e nA nL IIB+H2, T4, T3 or T2 or For PGC5000B: Ex d e pz IIB+H2, T4, T3 or T2 For PGC5000C: Ex d e nA nL IIB+H2, T4, T3 or T2 or For PGC5000C: Ex d e pz IIB+H2, T4, T3 or T2

(complete marking on page 4)

Approved for issue on behalf of the IECEx

Certification Body:

Position:

Signature: (for printed version)

Date:

Marc GILLAUX

Ex Certification Manager

2 2 JUIL, 2011

1. This certificate and schedule may only be reproduced in full.

2. This certificate is not transferable and remains the property of the issuing body.

3. The Status and authenticity of this certificate may be verified by visiting the Official IECEx Website.

Certificate issued by:

Laboratoire Central des Industries Electriques (LCIE)
33 Avenue du General Leclerc
FR-92260 Fontenay-aux-Roses
France





Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

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Issue No.: 4

Page 2 of 5

Manufacturer:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 **United States of America**

Manufacturing location(s):

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

This certificate is issued as verification that a sample(s), representative of production, was assessed and tested and found to comply with the IEC Standard list below and that the manufacturer's quality system, relating to the Ex products covered by this certificate, was assessed and found to comply with the IECEx Quality system requirements. This certificate is granted subject to the conditions as set out in IECEx Scheme Rules, IECEx 02 and Operational Documents as amended.

STANDARDS:

The electrical apparatus and any acceptable variations to it specified in the schedule of this certificate and the identified documents, was found to comply with the following standards:

IEC 60079-0: 2007-10

Edition: 5

IEC 60079-1: 2007-04

Edition: 6

IEC 60079-11: 2006

Edition: 5

IEC 60079-15: 2005-

03

Edition: 3

IEC 60079-2: 2007-02

Edition: 5

IEC 60079-7: 2006-07

Edition: 4

Explosive atmospheres - Part 0: Equipment - General requirements

Explosive atmospheres - Part 1: Equipment protection by flameproof enclosures "d"

Explosive atmospheres - Part 11: Equipment protection by intrinsic safety "i"

Electrical apparatus for explosive gas atmospheres Part 15: Construction, test and

Marking of Type of Protection "n" electrical apparatus

Explosive Atmospheres - Part 2 Equipment protection by pressurized enclosure "p"

Explosive atmospheres - Part 7: Equipment protection by increased safety "e"

This Certificate does not indicate compliance with electrical safety and performance requirements other than those expressly included in the Standards listed above.

TEST & ASSESSMENT REPORTS:

A sample(s) of the equipment listed has successfully met the examination and test requirements as recorded in

Test Report:

FR/LCI/ExTR09.0011/04

Quality Assessment Report:

NL/KEM/QAR09.0015/01



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2011-07-22

Issue No.: 4

Page 3 of 5

Schedule

EQUIPMENT:

Equipment and systems covered by this certificate are as follows:

The controller compartment PGC5000A (which controls from one to four Isothermal Ovens type PGC5000B or PGC5000C) houses a power supply and PCBs for the single board computer, oven controller and the front panel that employs an intrinsically safe circuit for the front panel mounted external keypad. The type PGC5000B and PGC5000C gas chromatograph are designed to operate automatically analyzing process streams and reporting the analysis of the analyzer. The type PGC5000B and PGC5000C gas chromatograph communicate the analytical detection and analytical process scheduling back and forth to the type PGC5000A Master Controller by means of fiber optic CAN bus. The PGC5000B and PGC5000C modules consist of the following three sections:

- 1.) The electronics compartment (located on the left side),
- 2.) The oven compartment (located on the right side), houses, as dependant upon the configuration / analytical application, the isothermal air-mass heater type 800-2, pneumatic actuated sample valves, TCD detectors type 002A or type 865, FID detector type 799, methanizer / air cleanup type 805-5 or type 862, or the LSV vaporizer heater block type 791. The oven compartment also includes the Type 867 Flame Photometric Detector (FPD). This Type 867 FPD shall be considered as an option to the PGC5000B. The FPD configuration is dependant upon the intended analytical application of the PGC5000B application. The components of the type 867 FPD are very similar to the previously submitted and approved type 804 FPD (see page 92 of this report for details). The purpose of the present modification report (issue 03) is to add the standard type 865-2 Thermal Conductivity Detector (TCD) which is application dependant and shall be compared to the previously examined standard type 002A TCD and multi-port type 865 TCD. The type 865-2 Thermal Conductivity Detector (TCD) has the identically same analytical ports as the previously examined type 865-2 TCD. The standard type 865-2 TCD does not have the additional wiring chamber or wiring conduct that was previously examined for the multi-port type 865 TCD. The flameproof construction of the standard type 865-2 TCD is identical to the previously examined type 002A TCD, certified LCIE 03ATEX0038U, except that the previous standard type 002A TCD employed external flame arrestors whereas the new standard type 865-2 TCD employs the same internal flame arrestors as the previously examined multi-port type 865 TCD, which inserts the internal flame arrestors inside of the analytical ports.
- 3.) The top compartment is exposed to hazardous atmosphere and houses the Electronic Pressure Control (EPC) type 801-2 and a manifold for incoming air as required for the air-operated solenoids and regulated purge air for the electronics and oven compartments.

The PGC5000C Smart Oven is physically larger than the previously examined PGC5000B by approximately 50% in volume, and is application dependant upon the analytical measurement. Regardless of the model PGC5000B or PGC5000C, the series PGC5000 Smart Oven houses and employs the identical internal components. For complex analytical applications, the PGC5000C Smart Oven is capable of operating simultaneous detectors (i.e. TCD or FID), two Electronic Pressure Controllers (EPC) and two Liquid Sample Valves (LSV). Such configurations can be compared to the previously examined PGC2000, IECEx LCI 07.0011 and ExTR LCIE 60054857-555326 (FRI/LCI/ExTR07.0008/00). The larger PGC5000C Smart Oven offers another access door to the internal electronics, due to the increased height of the enclosure, and a higher wattage air heater to effectively heat the isothermal oven compartment.

Due to the increase in electrical load, the electrical rating of the Smart Oven is specified as:

PGC5000A @ 120 VA maximum

PGC5000B @ 1200 VA maximum

PGC5000C @ 1600 VA maximum

CONDITIONS OF CERTIFICATION: YES as shown below:

Ambient temperature: 0 to 50°C.



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2011-07-22

Issue No.: 4

Page 4 of 5

EQUIPMENT(continued):

ABB Inc - Lewisburg - USA

Serial number / Year of manufacture / Certificate number / Ambient temperature : 0 to 50°C WARNING - DO NOT OPEN WHEN AN EXPLOSIVE ATMOSPHERE MAY BE PRESENT

For PGC5000A controller:

For ZONE 1:

Type: PGC5000A

Ex ib py IIB+H2 T4 or Ex ib px IIB+H2 T4 (with optional overpressure and purge control device)

Protective gas: Continuous flow, air Total internal free volume: 62L

Minimum air supply flow rate: 17.84 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 3.3 mbar

Maximum leakage flow rate: 21.66 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex ib nA nL IIB+H2 T4 or Ex pz IIB+H2 T4 (with optional overpressure and purge control device)

For PGC5000B and PGC5000C Oven Electronics:

Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

Protective gas : Continuous flow, air Total internal free volume : 37.94L

Minimum air supply flow rate: 39.36 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 1.76 mbar

Maximum leakage flow rate: 79.00 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

For PGC5000B and PGC5000C Isothermal oven : For ZONE 1:

Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

Protective gas: Continuous flow, air Total internal free volume: 36.81L Minimum air supply flow rate: 106.47 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 2.33 mbar

Maximum leakage flow rate: 169.05 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

ROUTINE VERIFICATIONS AND TESTS

For pressurized compartments including PGC5000A controller, PGC5000B Oven Electronics, PGC5000B Isothermal oven, PGC5000C Oven Electronics, PGC5000C Isothermal oven, heating device 800-2:

- IEC60079-2 / §17.1: The performance of safety devices shall be verified.

- IEC60079-2 / §17.2 : The measured flow rate shall be not greater than the maximum leakage flow rate specified by the manufacturer.

- EN60079-15 / §34.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For heating device 800-2 and 800:

IEC60079-0 / §5: Checking of the safety device and the tempearature class.

- IEC60079-7 / §7.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For FID detector 799:

- IEC60079-1 / §16 : Routine test under the pressure of 20 bar during at least 10 s without exceeding 1 minute (welded construction).



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IECEx LCI 09.0010X

Date of Issue:

2011-07-22

Issue No.: 4

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DETAILS OF CERTIFICATE CHANGES (for issues 1 and above):

The purpose of this report is :Inclusion of improved Digital Temperature Controller printed circuit boards housed within the oven electronics enclosure, and addition of the new model PGC5007 Fuel Sulfur Analyzer, including the type 868 furnace housed within the isothermal oven of the PGC5000B



INTERNATIONAL ELECTROTECHNICAL COMMISSION IEC Certification Scheme for Explosive Atmospheres

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IECEx LCI 09.0010X

issue No.:3

Status:

Current

Date of Issue:

2010-03-31

Page 1 of 5

Certificate history:

Issue No. 3 (2010-3-31) Issue No. 2 (2009-11-6) Issue No. 1 (2009-10-28)

Issue No. 0 (2009-3-9)

Applicant:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

Electrical Apparatus: Optional accessory:

Gas Chromatograph Analyzer - PGC5000A, PGC5000B, PGC5000C

Type of Protection:

ib py / d e py OR ib px / d e ib px OR nA nL / d e nA nL OR pz / d e pz

Marking:

For zone 1:

For PGC5000A: Ex ib py IIB+H2 T4 or

For PGC5000A : Ex ib px IIB+H2 T4

For PGC5000B: Ex d e py IIB+H2, T4, T3 or T2 or For PGC5000B: Ex d e ib px IIB+H2, T4, T3 or T2 For PGC5000C: Ex d e py IIB+H2, T4, T3 or T2 or FGC5000C: Ex d e ib px IIB+H2, T4, T3 or T2

For zone 2:

For PGC5000A: Ex nA nL IIB+H2 T4 or

For PGC5000A: Ex pz IIB+H2 T4

For PGC5000B: Ex d e nA nL IIB+H2, T4, T3 or T2 or For PGC5000B: Ex d e pz IIB+H2, T4, T3 or T2 For PGC5000C: Ex d e nA nL IIB+H2, T4, T3 or T2 or For PGC5000C: Ex d e pz IIB+H2, T4, T3 or T2

(complete marking on page 4)

Approved for issue on behalf of the IECEx

Certification Body:

Position:

Signature: (for printed version)

Date:

Marc GILLAUX

Ex Certification Manager

0 2 JUIN 2010

1. This certificate and schedule may only be reproduced in full.

2. This certificate is not transferable and remains the property of the issuing body.

3. The Status and authenticity of this certificate may be verified by visiting the Official IECEx Website.

Certificate issued by:

Laboratoire Central des Industries Electriques (LCIE) 33 Avenue du General Leclerc FR-92260 Fontenay-aux-Roses France





Certificate No.: IECEx LCI 09.0010X

Date of Issue: 2010-03-31 Issue No.: 3

Page 2 of 5

Manufacturer: ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

Manufacturing location(s):

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

This certificate is issued as verification that a sample(s), representative of production, was assessed and tested and found to comply with the IEC Standard list below and that the manufacturer's quality system, relating to the Ex products covered by this certificate, was assessed and found to comply with the IECEx Quality system requirements. This certificate is granted subject to the conditions as set out in IECEx Scheme Rules, IECEx 02 and Operational Documents as amended.

STANDARDS:

The electrical apparatus and any acceptable variations to it specified in the schedule of this certificate and the identified documents, was found to comply with the following standards:

IEC 60079-0: 2004 Electrical apparatus for explosive gas atmospheres - Part 0: General requirements

Edition: 4.0

IEC 60079-1: 2003 Electrical apparatus for explosive gas atmospheres - Part 1: Flameproof enclosure 'd'

Edition: 5

IEC 60079-11: 2006 Explosive atmospheres - Part 11: Equipment protection by intrinsic safety "i"

Edition: 5

IEC 60079-15 : 2005- Electrical apparatus for explosive gas atmospheres Part 15: Construction, test and

03 Marking of Type of Protection "n" electrical apparatus

Edition: 3

IEC 60079-2: 2001 Electrical apparatus for explosive gas atmospheres - Part 2: Pressurized enclosures 'p'

Edition: 4

IEC 60079-7: 2006-07 Explosive atmospheres - Part 7: Equipment protection by increased safety "e"

Edition: 4

This Certificate does not indicate compliance with electrical safety and performance requirements other than those expressly included in the Standards listed above.

TEST & ASSESSMENT REPORTS:

A sample(s) of the equipment listed has successfully met the examination and test requirements as recorded in

Test Report:

FR/LCI/ExTR09.0011/03

Quality Assessment Report: NL/KEM/QAR09.0015/00



Certificate No.: IECEx LCI 09.0010X

Date of Issue: 2010-03-31 Issue No.: 3

Page 3 of 5

Schedule

EQUIPMENT:

Equipment and systems covered by this certificate are as follows:

The controller compartment PGC5000A (which controls from one to four Isothermal Ovens type PGC5000B or PGC5000C) houses a power supply and PCBs for the single board computer, oven controller and the front panel that employs an intrinsically safe circuit for the front panel mounted external keypad. The type PGC5000B and PGC5000C gas chromatograph are designed to operate automatically analyzing process streams and reporting the analysis of the analyzer. The type PGC5000B and PGC5000C gas chromatograph communicate the analytical detection and analytical process scheduling back and forth to the type PGC5000A Master Controller by means of fiber optic CAN bus. The PGC5000B and PGC5000C modules consist of the following three sections:

- 1.) The electronics compartment (located on the left side),
- 2.) The oven compartment (located on the right side) , houses, as dependant upon the configuration / analytical application, the isothermal air-mass heater type 800-2, pneumatic actuated sample valves, TCD detectors type 002A or type 865, FID detector type 799, methanizer / air cleanup type 805-5 or type 862, or the LSV vaporizer heater block type 791. The oven compartment also includes the Type 867 Flame Photometric Detector (FPD). This Type 867 FPD shall be considered as an option to the PGC5000B. The FPD configuration is dependant upon the intended analytical application of the PGC5000B application. The components of the type 867 FPD are very similar to the previously submitted and approved type 804 FPD (see page 92 of this report for details). The purpose of the present modification report (issue 03) is to add the standard type 865-2 Thermal Conductivity Detector (TCD) which is application dependant and shall be compared to the previously examined standard type 002A TCD and multi-port type 865 TCD. The type 865-2 Thermal Conductivity Detector (TCD) has the identically same analytical ports as the previously examined type 865-2 TCD. The standard type 865-2 TCD does not have the additional wiring chamber or wiring conduct that was previously examined for the multi-port type 865 TCD. The flameproof construction of the standard type 865-2 TCD is identical to the previously examined type 002A TCD, certified LCIE 03ATEX0038U, except that the previous standard type 002A TCD employed external flame arrestors whereas the new standard type 865-2 TCD employs the same internal flame arrestors as the previously examined multi-port type 865 TCD, which inserts the internal flame arrestors inside of the analytical ports.
- 3.) The top compartment is exposed to hazardous atmosphere and houses the Electronic Pressure Control (EPC) type 801-2 and a manifold for incoming air as required for the air-operated solenoids and regulated purge air for the electronics and oven compartments.

The PGC5000C Smart Oven is physically larger than the previously examined PGC5000B by approximately 50% in volume, and is application dependant upon the analytical measurement. Regardless of the model PGC5000B or PGC5000C, the series PGC5000 Smart Oven houses and employs the identical internal components. For complex analytical applications, the PGC5000C Smart Oven is capable of operating simultaneous detectors (i.e. TCD or FID), two Electronic Pressure Controllers (EPC) and two Liquid Sample Valves (LSV). Such configurations can be compared to the previously examined PGC2000, IECEx LCI 07.0011 and ExTR LCIE 60054857-555326 (FRI/LCI/ExTR07.0008/00). The larger PGC5000C Smart Oven offers another access door to the internal electronics, due to the increased height of the enclosure, and a higher wattage air heater to effectively heat the isothermal oven compartment.

Due to the increase in electrical load, the electrical rating of the Smart Oven is specified as:

PGC5000A @ 120 VA maximum

PGC5000B @ 1200 VA maximum

PGC5000C @ 1600 VA maximum

CONDITIONS OF CERTIFICATION: YES as shown below:

Ambient temperature: 0 to 50°C.



of Conformity

Certificate No.: IECEx LCI 09.0010X

Date of Issue: 2010-03-31 Issue No.: 3

Page 4 of 5

EQUIPMENT(continued):

MARKING:

ABB Inc - Lewisburg - USA

Serial number / Year of manufacture / Certificate number / Ambient temperature : 0 to 50°C WARNING - DO NOT OPEN WHEN AN EXPLOSIVE ATMOSPHERE MAY BE PRESENT

For PGC5000A controller:

For ZONE 1:

Type: PGC5000A

Ex ib py IIB+H2 T4 or Ex ib px IIB+H2 T4 (with optional overpressure and purge control device)

Protective gas : Continuous flow, air Total internal free volume : 62L

Minimum air supply flow rate: 17.84 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 3.3 mbar

Maximum leakage flow rate: 21.66 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex ib nA nL IIB+H2 T4 or Ex pz IIB+H2 T4 (with optional overpressure and purge control device)

For PGC5000B and PGC5000C Oven Electronics:

For ZONE 1:

Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

Protective gas: Continuous flow, air Total internal free volume: 37.94L Minimum air supply flow rate: 39.36 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 1.76 mbar

Maximum leakage flow rate: 79.00 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

For PGC5000B and PGC5000C Isothermal oven:

For ZONE 1:

Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

Protective gas: Continuous flow, air Total internal free volume: 36.81L Minimum air supply flow rate: 106.47 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 2.33 mbar

Maximum leakage flow rate: 169.05 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

ROUTINE VERIFICATIONS AND TESTS

For pressurized compartments including PGC5000A controller, PGC5000B Oven Electronics, PGC5000B Isothermal oven, PGC5000C Oven Electronics, PGC5000C Isothermal oven, heating device 800-2:

IEC60079-2 / §17.1: The performance of safety devices shall be verified.

- IEC60079-2 / §17.2 : The measured flow rate shall be not greater than the maximum leakage flow rate specified by the manufacturer.
- EN60079-15 / §34.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For heating device 800-2 and 800:

- IEC60079-0 / §5 : Checking of the safety device and the tempearature class.
- IEC60079-7 / §7.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For FID detector 799 :

- IEC60079-1 / §16: Routine test under the pressure of 20 bar during at least 10 s without exceeding 1 minute (welded construction).



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2010-03-31

Issue No.: 3

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DETAILS OF CERTIFICATE CHANGES (for issues 1 and above):

Initial Issue:

Initial issue based on tests performed by CSA International, Toronto

Issue 01:

Addition of the optional overpressure and purge control device (x-purge option).

Issue 02:

Addition of the optional flame photometric detector type 867 FPD in the oven compartment of the PGC5000B

Issue 03:

Addition of the optional Extended I/O devices within the PGC5000A, the Malema flow switch and type 865-2 Thermal Conductive Detector (TCD) for the isothermal oven and the inclusion of the PGC5000C Smart Oven



of Conformity

INTERNATIONAL ELECTROTECHNICAL COMMISSION IEC Certification Scheme for Explosive Atmospheres

for rules and details of the IECEx Scheme visit www.iecex.com

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IECEx LCI 09.0010X

issue No.:2

Status:

Current

Date of Issue:

2009-11-06

Page 1 of 5

Certificate history: Issue No. 2 (2009-11-6) Issue No. 1 (2009-10-

28) Issue No. 0 (2009-3-9)

Applicant:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

Electrical Apparatus:

Gas Chromatograph Analyzer - PGC5000A, PGC5000B

Optional accessory:

Type of Protection:

......

ib py / d e py OR ib px / d e ib px OR nA nL / d e nA nL OR pz / d e pz

Marking:

For zone 1:

For PGC5000A: Ex ib py IIB+H2 T4 or For PGC5000A: Ex ib px IIB+H2 T4

For PGC5000B : Ex d e py IIB+H2, T4, T3 or T2 or For PGC5000B : Ex d e ib px IIB+H2, T4, T3 or T2

For zone 2:

For PGC5000A: Ex nA nL IIB+H2 T4 or

For PGC5000A: Ex pz IIB+H2 T4

For PGC5000B : Ex d e nA nL IIB+H2, T4, T3 or T2 or For PGC5000B : Ex d e pz IIB+H2, T4, T3 or T2

Approved for issue on behalf of the IECEx

Certification Body:

Position:

Signature: (for printed version)

Date:

Marc GILLAUX

Ex Certification Manager

0 6 NOV.

1. This certificate and schedule may only be reproduced in full.

2. This certificate is not transferable and remains the property of the issuing body.

3. The Status and authenticity of this certificate may be verified by visiting the Official IECEx Website.

Certificate issued by:

Laboratoire Central des Industries Electriques (LCIE) 33 Avenue du General Leclerc FR-92260 Fontenay-aux-Roses France





Certificate No.:

IECEX LCI 09.0010X

Date of Issue:

2009-11-06

Issue No.: 2

Page 2 of 5

Manufacturer:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

Manufacturing location(s):

ABB Inc. 843, North Jefferson Street Lewisburg, WV 24901 United States of America

This certificate is issued as verification that a sample(s), representative of production, was assessed and tested and found to comply with the IEC Standard list below and that the manufacturer's quality system, relating to the Ex products covered by this certificate, was assessed and found to comply with the IECEx Quality system requirements. This certificate is granted subject to the conditions as set out in IECEx Scheme Rules, IECEx 02 and Operational Documents as amended.

STANDARDS:

The electrical apparatus and any acceptable variations to it specified in the schedule of this certificate and the identified documents, was found to comply with the following standards:

IEC 60079-0: 2004

Electrical apparatus for explosive gas atmospheres - Part 0: General requirements

Edition: 4.0

IEC 60079-1: 2003

Electrical apparatus for explosive gas atmospheres - Part 1: Flameproof enclosure 'd'

Edition: 5

IEC 60079-11: 2006

Explosive atmospheres - Part 11: Equipment protection by intrinsic safety "i"

Edition: 5

IEC 60079-15 : 2005-

Electrical apparatus for explosive gas atmospheres Part 15: Contruction, test and Marking of Type of Protection "n" electrical apparatus

03

Edition: 3

IEC 60079-2:2001

Edition: 4

Electrical apparatus for explosive gas atmospheres - Part 2: Pressurized enclosures 'p'

IEC 60079-7: 2006-07

Explosive atmospheres - Part 7: Equipment protection by increased safety "e"

Edition: 4

This Certificate does not indicate compliance with electrical safety and performance requirements other than those expressly included in the Standards listed above.

TEST & ASSESSMENT REPORTS:

A sample(s) of the equipment listed has successfully met the examination and test requirements as recorded in

Test Report:

FR/LCI/ExTR09.0011/02

Quality Assessment Report: NL/KEM/QAR09.0015/00



of Conformity

Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-11-06

Issue No.: 2

Page 3 of 5

Schedule

EQUIPMENT:

Equipment and systems covered by this certificate are as follows:

The controller compartment PGC5000A (which controls from one to four Isothermal Ovens type PGC5000B) houses a power supply and PCBs for the single board computer, oven controller and the front panel that employs an intrinsically safe circuit for the front panel mounted external keypad.

The type PGC5000B gas chromatograph is designed to operate automatically analyzing process streams and reporting the analysis of the analyzer. The type PGC5000B gas chromatograph communicates the analytical detection and analytical process scheduling back and forth to the type PGC5000A Master Controller by means of fiber optic CAN bus.

The PGC5000B module consists of the following three sections:

- 1.) The electronics compartment (located on the left side),
- 2.) The oven compartment (located on the right side), houses, as dependent upon the configuration / analytical application, the isothermal air-mass heater type 800-2, pneumatic actuated sample valves, TCD detectors type 002A or type 865, FID detector type 799, methanizer / air cleanup type 805-5 or type 862, or the LSV vaporizer heater block type 791.

The purpose of the present certificate (issue 02) is to add the Type 867 Flame Photometric Detector (FPD) in the oven compartment. This Type 867 FPD shall be considered as an option to the previously submitted and approved PGC5000B. The FPD configuration is dependant upon the intended analytical application of the PGC5000B application. The components of the type 867 FPD are very similar to the previously submitted and approved type 804 FPD.

3.) The top compartment is exposed to hazardous atmosphere and houses the Electronic Pressure Control (EPC) type 801-2 and a manifold for incoming air as required for the air-operated solenoids and regulated purge air for the electronics and oven compartments.

PCG5000A: 120Vac / 240Vac, 50/60 Hz, 120VA PCG5000B: 120Vac / 240Vac, 50/60 Hz, 1200VA

CONDITIONS OF CERTIFICATION: YES as shown below:

Ambient temperature: 0 to 50°C.



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-11-06

Issue No.: 2

Page 4 of 5

EQUIPMENT(continued):

MARKING:

ABB Inc - Lewisburg - USA

Serial number / Year of manufacture / Certificate number / Ambient temperature : 0 to 50°C WARNING – DO NOT OPEN WHEN AN EXPLOSIVE ATMOSPHERE MAY BE PRESENT

For PGC5000A controller:

For ZONE 1:

Type: PGC5000A

Ex ib py IIB+H2 T4 or Ex ib px IIB+H2 T4 (with optional overpressure and purge control device)

Protective gas : Continuous flow, air Total internal free volume : 62L

Minimum air supply flow rate: 17.84 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 3.3 mbar

Maximum leakage flow rate: 21.66 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex ib nA nL IIB+H2 T4 or Ex pz IIB+H2 T4 (with optional overpressure and purge control device)

For PGC5000B Oven Electronics:

For ZONE 1:

Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

Protective gas: Continuous flow, air Total internal free volume: 37.94L Minimum air supply flow rate: 39.36 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 1.76 mbar

Maximum leakage flow rate: 79.00 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

For PGC5000B Isothermal oven:

For ZONE 1:

Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

Protective gas: Continuous flow, air Total internal free volume: 36.81L Minimum air supply flow rate: 106.47 L/Min.

Minimum overpressure: 0.5 mbar / Maximum overpressure: 2.33 mbar

Maximum leakage flow rate: 169.05 L/Min

Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control)

ROUTINE VERIFICATIONS AND TESTS

For pressurized compartments including PGC5000A controller, PGC5000B Oven Electronics and PGC5000B Isothermal oven, heating device 800-2:

- IEC60079-2 / §17.1 : The performance of safety devices shall be verified.

- IEC60079-2 / §17.2 : The measured flow rate shall be not greater than the maximum leakage flow rate specified by the manufacturer.
- EN60079-15 / §34.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For heating device 800-2:

- IEC60079-0 / §5 : Checking of the safety device and the tempearature class.

- IEC60079-7 / §7.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For FID detector 799:

 - IEC60079-1 / §16: Routine test under the pressure of 20 bar during at least 10 s without exceeding 1 minute (welded construction).



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-11-06

Issue No.: 2

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DETAILS OF CERTIFICATE CHANGES	for issues 1	and above)
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The purpose of the Issue No. 02 is to add the optional Type 867 Flame Photometric Detector (FPD) in the oven compartment.



INTERNATIONAL ELECTROTECHNICAL COMMISSION **IEC Certification Scheme for Explosive Atmospheres**

for rules and details of the IECEx Scheme visit www.iecex.com

Certificate No.:

IECEx LCI 09.0010X

issue No.:1

Certificate history:

Status:

Current

Issue No. 1 (2009-10-28)

Issue No. 0 (2009-3-9)

Date of Issue:

2009-10-28

Page 1 of 5

Applicant:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 **United States of America**

Electrical Apparatus:

Gas Chromatograph Analyzer - PGC5000A, PGC5000B

Optional accessory:

Type of Protection:

ib py / d e py OR ib px / d e ib px OR nA nL / d e nA nL OR pz / d e pz

Marking:

For zone 1:

For PGC5000A: Ex ib py IIB+H2 T4 or

For PGC5000A: Ex ib px IIB+H2 T4
For PGC5000B: Ex d e py IIB+H2, T4, T3 or T2 or For PGC5000B: Ex d e ib px IIB+H2, T4, T3 or T2

For zone 2:

For PGC5000A: Ex nA nL IIB+H2 T4 or

For PGC5000A: Ex pz IIB+H2 T4

For PGC5000B: Ex d e nA nL IIB+H2, T4, T3 or T2 or For PGC5000B: Ex d e pz IIB+H2, T4, T3 or T2

Approved for issue on behalf of the IECEx

Certification Body:

Marc GILLAUX

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Position:

Signature:

(for printed version)

Date:

Ex Certification Manager

1. This certificate and schedule may only be reproduced in full.

2. This certificate is not transferable and remains the property of the issuing body

3. The Status and authenticity of this certificate may be verified by visiting the Official IECEx Website.

Certificate issued by:

Laboratoire Central des Industries Electriques (LCIE) 33 Avenue du General Leclerc FR-92260 Fontenay-aux-Roses France





Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-10-28

Issue No.: 1

Page 2 of 5

Manufacturer:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 **United States of America**

Manufacturing location(s):

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

This certificate is issued as verification that a sample(s), representative of production, was assessed and tested and found to comply with the IEC Standard list below and that the manufacturer's quality system, relating to the Ex products covered by this certificate, was assessed and found to comply with the IECEx Quality system requirements. This certificate is granted subject to the conditions as set out in IECEx Scheme Rules, IECEx 02 and Operational Documents as amended.

STANDARDS:

The electrical apparatus and any acceptable variations to it specified in the schedule of this certificate and the identified documents, was found to comply with the following standards:

IEC 60079-0: 2004

Electrical apparatus for explosive gas atmospheres - Part 0: General requirements

Edition: 4.0

IEC 60079-1: 2003

Electrical apparatus for explosive gas atmospheres - Part 1: Flameproof enclosure 'd'

Edition: 5

IEC 60079-11: 2006

Explosive atmospheres - Part 11: Equipment protection by intrinsic safety "i"

Edition: 5

Electrical apparatus for explosive gas atmospheres Part 15: Contruction, test and

IEC 60079-15: 2005-03

Marking of Type of Protection "n" electrical apparatus

Edition: 3

IEC 60079-2: 2001

Edition: 4

Electrical apparatus for explosive gas atmospheres - Part 2: Pressurized enclosures 'p'

IEC 60079-7: 2006-07

Explosive atmospheres - Part 7: Equipment protection by increased safety "e"

Edition: 4

This Certificate does not indicate compliance with electrical safety and performance requirements other than those expressly included in the Standards listed above.

TEST & ASSESSMENT REPORTS:

A sample(s) of the equipment listed has successfully met the examination and test requirements as recorded in

Test Report:

FR/LCI/ExTR09.0011/01

Quality Assessment Report: NL/KEM/QAR09.0015/00



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-10-28

Issue No.: 1

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Schedule

EQUIPMENT:

Equipment and systems covered by this certificate are as follows:

The controller compartment PGC5000A (which controls from one to four Isothermal Ovens type PGC5000B) houses a power supply and PCBs for the single board computer, oven controller and the front panel that employs an intrinsically safe circuit for the front panel mounted external keypad.

The type PGC5000B gas chromatograph is designed to operate automatically analyzing process streams and reporting the analysis of the analyzer. The type PGC5000B gas chromatograph communicates the analytical detection and analytical process scheduling back and forth to the type PGC5000A Master Controller by means of fiber optic CAN bus.

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Ambient temperature: 0 to 50°C.



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-10-28

Issue No.: 1

Page 4 of 5

EQUIPMENT(continued):

The PGC5000B module consists of the following three sections:

- 1.) The electronics compartment (located on the left side),
- 2.) The oven compartment (located on the right side), houses, as dependent upon the configuration / analytical application, the isothermal air-mass heater type 800-2, pneumatic actuated sample valves, TCD detectors type 002A or type 865, FID detector type 799, methanizer / air cleanup type 805-5 or type 862, or the LSV vaporizer heater block type 791.
- 3.) The top compartment is exposed to hazardous atmosphere and houses the Electronic Pressure Control (EPC) type 801-2 and a manifold for incoming air as required for the air-operated solenoids and regulated purge air for the electronics and oven compartments.

PCG5000A: 120Vac / 240Vac, 50/60 Hz, 120VA PCG5000B: 120Vac / 240Vac, 50/60 Hz, 1200VA

MARKING:

ABB Inc - Lewisburg - USA

Serial number / Year of manufacture

Certificate number

Ambient temperature: 0 to 50°C

WARNING - DO NOT OPEN WHEN AN EXPLOSIVE ATMOSPHERE MAY BE PRESENT

For PGC5000A controller:

For ZONE 1:

Type: PGC5000A

Ex ib py IIB+H2 T4 or Ex ib px IIB+H2 T4 (with optional overpressure and purge control device)

Protective gas : Continuous flow, air Total internal free volume : 62L

Minimum air supply flow rate: 17.84 L/Min. Minimum overpressure: 0.5 mbar Maximum leakage flow rate: 21.66 L/Min Maximum overpressure: 3.3 mbar

Purge wait time : 18.20 Min

or For ZONE 2:

Ex ib nA nL IIB+H2 T4 or Ex pz IIB+H2 T4 (with optional overpressure and purge control device)

For PGC5000B Oven Electronics:

For ZONE 1: Type : PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control

device)

Protective gas : Continuous flow, air Total internal free volume : 37.94L

Minimum air supply flow rate: 39.36 L/Min. Minimum overpressure: 0.5 mbar Maximum leakage flow rate: 79.00 L/Min Maximum overpressure: 1.76 mbar

Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control device)

For PGC5000B Isothermal oven:

For ZONE 1: Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 or Ex d e ib px IIB+H2 T4, T3 or T2 (with optional overpressure and purge control

device)

Protective gas : Continuous flow, air Total internal free volume : 36.81L

Minimum air supply flow rate: 106.47 L/Min.

Minimum overpressure : 0.5 mbar Maximum leakage flow rate : 169.05 L/Min Maximum overpressure : 2.33 mbar

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Purge wait time: 18.20 Min

or For ZONE 2:

Ex d e nA nL IIB+H2, T4, T3 or T2 or Ex d e pz IIB+H2 T4, T3 or T2 (with optional overpressure and purge control device)

ROUTINE VERIFICATIONS AND TESTS

For pressurized compartments including PGC5000A controller, PGC5000B Oven Electronics and PGC5000B Isothermal oven, heating device 800-2:

- IEC60079-2 / §17.1 : The performance of safety devices shall be verified.

- IEC60079-2 / §17.2 : The measured flow rate shall be not greater than the maximum leakage flow rate specified by the manufacturer.
- EN60079-15 / §34.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For heating device 800-2:

- IEC60079-0 / §5 : Checking of the safety device and the tempearature class.

- IEC60079-7 / §7.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For FID detector 799:

- IEC60079-1 / §16 : Routine test under the pressure of 20 bar during at least 10 s without exceeding 1 minute (welded construction).



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IECEx LCI 09.0010X

Date of Issue:

2009-10-28

Issue No.: 1

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DETAILS OF	CERTIFICATE	CHANGES	for issues 1	and above)
DE IAILS OF	CENTIFICATE	CHANGES	IUI ISSUES I	and above.

The purpose of the issue No. 1 is to add an optional overpressure and purge control device for compliance to the 'px' requirements.



INTERNATIONAL ELECTROTECHNICAL COMMISSION IEC Certification Scheme for Explosive Atmospheres for rules and details of the IECEx Scheme visit www.iecex.com

	IECEx LCI 09.0010X	issue No.:0	Certificate history:
Status:	Current		
Date of Issue:	2009-03-09	Page 1 of 4	
Applicant:	ABB Inc. 843, North Jefferson Stre- Lewisburg, WV 24901 United States of Amer		
Electrical Apparatus: Optional accessory:	Gas Chromatograph An	alyzer - PGC5000A, PGC5000B	
Type of Protection:	ib py/d e py or nA nL/d e	e nA nL	
Marking:	For zone 1: For PGC5000A: Ex ib py For PGC5000B: Ex d e p For zone 2: For PGC5000A: Ex nA r For PGC5000B: Ex d e p	oy IIB+H2, T4, T3 or T2	
Approved for issue on be Certification Body:	ehalf of the IECEx	Marc GILLAUX	
Position:		Ex Certification Manager	
Signature: (for printed version)		- Chant	_
Date: 21/04	12009	(

Certificate issued by:

Laboratoire Central des Industries Electriques (LCIE) 33 Avenue du General Leclerc FR-92260 Fontenay-aux-Roses France





Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-03-09

Issue No.: 0

Page 2 of 4

Manufacturer:

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 **United States of America**

Manufacturing location(s):

ABB Inc.

843, North Jefferson Street Lewisburg, WV 24901 United States of America

This certificate is issued as verification that a sample(s), representative of production, was assessed and tested and found to comply with the IEC Standard list below and that the manufacturer's quality system, relating to the Ex products covered by this certificate, was assessed and found to comply with the IECEx Quality system requirements. This certificate is granted subject to the conditions as set out in IECEx Scheme Rules, IECEx 02 and Operational Documents as amended.

STANDARDS:

The electrical apparatus and any acceptable variations to it specified in the schedule of this certificate and the identified documents, was found to comply with the following standards:

IEC 60079-0: 2004

Electrical apparatus for explosive gas atmospheres - Part 0: General requirements

Edition: 4.0

IEC 60079-1: 2003

Electrical apparatus for explosive gas atmospheres - Part 1: Flameproof enclosure 'd'

Edition: 5

IEC 60079-11: 2006

Edition: 5

Explosive atmospheres - Part 11: Equipment protection by intrinsic safety "i"

IEC 60079-15: 2005-

Electrical apparatus for explosive gas atmospheres Part 15: Contruction, test and

03

Marking of Type of Protection "n" electrical apparatus

Edition: 3

IEC 60079-2: 2001

Edition: 4

Electrical apparatus for explosive gas atmospheres - Part 2: Pressurized enclosures 'p'

IEC 60079-7: 2006-07

Edition: 4

Explosive atmospheres - Part 7: Equipment protection by increased safety "e"

This Certificate does not indicate compliance with electrical safety and performance requirements other than those expressly included in the Standards listed above.

TEST & ASSESSMENT REPORTS:

A sample(s) of the equipment listed has successfully met the examination and test requirements as recorded in

Test Report:

FR/LCI/ExTR09.0011/00

Quality Assessment Report: NL/KEM/QAR09.0015/00



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IECEx LCI 09.0010X

Date of Issue:

2009-03-09

Issue No.: 0

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Schedule

EQUIPMENT:

Equipment and systems covered by this certificate are as follows:

The controller compartment PGC5000A (which controls from one to four Isothermal Ovens type PGC5000B) houses a power supply and PCBs for the single board computer, oven controller and the front panel that employs an intrinsically safe circuit for the front panel mounted external keypad.

The type PGC5000B gas chromatograph is designed to operate automatically analyzing process streams and reporting the analysis of the analyzer. The type PGC5000B gas chromatograph communicates the analytical detection and analytical process scheduling back and forth to the type PGC5000A Master Controller by means of fiber optic CAN bus.

CONDITIONS OF CERTIFICATION: YES as shown below:

Ambient temperature: 0 to 50°C.



Certificate No.:

IECEx LCI 09.0010X

Date of Issue:

2009-03-09

Issue No.: 0

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EQUIPMENT(continued):

The PGC5000B module consists of the following three sections:

- 1.) The electronics compartment (located on the left side),
- 2.) The oven compartment (located on the right side), houses, as dependant upon the configuration / analytical application, the isothermal air-mass heater type 800-2, pneumatic actuated sample valves, TCD detectors type 002A or type 865, FID detector type 799, methanizer / air cleanup type 805-5 or type 862, or the LSV vaporizer heater block type 791.
- 3.) The top compartment is exposed to hazardous atmosphere and houses the Electronic Pressure Control (EPC) type 801-2 and a manifold for incoming air as required for the air-operated solenoids and regulated purge air for the electronics and oven compartments.

PCG5000A: 120Vac / 240Vac, 50/60 Hz, 120VA PCG5000B: 120Vac / 240Vac, 50/60 Hz, 1200VA

MARKING:

ABB Inc - Lewisburg - USA Serial number / Year of manufacture Certificate number

Ambient temperature: 0 to 50°C

WARNING - DO NOT OPEN WHEN AN EXPLOSIVE ATMOSPHERE MAY BE PRESENT

For PGC5000A controller:

Type: PGC5000A Ex ib py IIB+H2 T4

Protective gas: Continuous flow, air Total internal free volume: 62L

Minimum air supply flow rate: 17.84 L/Min.

Minimum overpressure: 0.5 mbar Maximum leakage flow rate: 21.66 L/Min Maximum overpressure: 3.3 mbar Purge wait time: 18.20 Min

Ex ib nA nL IIB+H2 T4 (For zone 2)

For PGC5000B Oven Electronics:

Type: PGC5000B

Ex de py IIB+H2, T4, T3 or T2 Protective gas: Continuous flow, air Total internal free volume: 37.94L

Minimum air supply flow rate: 39.36 L/Min.

Minimum overpressure: 0.5 mbar Maximum leakage flow rate: 79.00 L/Min Maximum overpressure: 1.76 mbar Purge wait time: 18.20 Min

Ex d e nA nL IIB+H2, T4, T3 or T2 (For zone 2)

For PGC5000B Isothermal oven:

Type: PGC5000B

Ex d e py IIB+H2, T4, T3 or T2 Protective gas : Continuous flow, air Total internal free volume: 36.81L

Minimum air supply flow rate: 106.47 L/Min. Minimum overpressure: 0.5 mbar

Maximum leakage flow rate: 169.05 L/Min Maximum overpressure: 2.33 mbar

Purge wait time: 18.20 Min

or:

Ex d e nA nL IIB+H2, T4, T3 or T2 (For zone 2)

ROUTINE VERIFICATIONS AND TESTS

For pressurized compartments including PGC5000A controller, PGC5000B Oven Electronics and PGC5000B Isothermal oven, heating device 800-2:

- IEC60079-2 / §17.1: The performance of safety devices shall be verified.
- IEC60079-2 / §17.2 : The measured flow rate shall be not greater than the maximum leakage flow rate specified by the manufacturer.
- EN60079-15 / §34.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For heating device 800-2:

- IEC60079-0 / §5: Checking of the safety device and the tempearature class.
- IEC60079-7 / §7.2 : Dielectric strength shall be verified by a test at the test voltage 1500 V r.m.s. and maintained for at least 1 min.

For FID detector 799:

- IEC60079-1 / §16: Routine test under the pressure of 20 bar during at least 10 s without exceeding 1 minute (welded construction).